

Notice of References Cited	Application/Control No. 10/572,855		Applicant(s)/Patent Under Reexamination SHIMADA ET AL.	
	Examiner JOHN K. KIM		Art Unit 2834	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0201685	10-2003	Shimada et al.	310/156.53
*	B	US-2002/0114824	08-2002	Fukui et al.	424/432
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

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